

ALDERMAN, 36TH WARD 6560 WEST FULLERTON AVENUE UNIT # C118 - SUITE A CHICAGO, ILLINOIS 60707 WARD36@CITYOFCHICAGO.ORG (773) 745-4636 COMMITEE CHAIRMAN ECONOMIC, CAPITAL, AND TECHNOLOGY DEVELOPMENT COMMITEE VICE CHAIRMAN COMMITEES AND RULES COMMITEE MEMBERSHIPS ZONING, LANDMARKS, AND BUILDING STANDARDS BUDGET AND GOVERNMENT OPERATIONS CONTRACTING OVERSIGHT AND EQUALITY LICENSE AND CONSUMER PROTECTION WORKFORCE DEVELOPMENT AVIATION FINANCE

MEETING NOTICE AND AGENDA

GILBERT VILLEGAS CITY COUNCIL

CITY OF CHICAGO

..... Council Chamber

CITY HALL - 2ND FLOOR 121 NORTH LASALLE STREET CHICAGO, ILLINOIS 60602

You are hereby notified that the Chicago City Council **Committee on Economic, Capital and Technology Development** will hold a virtual meeting on **Tuesday, November 09, 2021** at **1:20 PM** to discuss the following:

O2021 – 4140 Ward(s): Sponsor(s): Department of Planning and Development

Public hearing(s) on establishment of Special Service Area No. 79, determination of ten year tax levy rate, selection of special services from approximate taxable area of W Lawrence Ave from N Knox Ave to N Pulaski Rd; N Pulaski Rd from W Ainslie St to N Elston Ave; and N Elston Ave from W Lawrence Ave to W Harding Ave

Pursuant to applicable law, the Chairman has determined that an in-person meeting is not practical or prudent. Accordingly, attendance at this meeting will be by remote means only. Instructions for how to attend this meeting and participate in oral public comment will be provided on the Chicago City Clerk's website [http://www.chicityclerk.com/].

Written public comment on any of the items listed on the Agenda will be accepted at ECTD@cityofchicago.org until 12:20 P.M. on Monday, November 08, 2021.

Copies of the Agenda of Matters to be considered at this meeting will be made available electronically on the City Clerk's website.

NOTE: City Hall is closed to the public, until a date to be determined, due to the current circumstances concerning COVID-19.

Gilbert Villegas, Chairman Committee on Economic, Capital and Technology Development